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) Group Art Unit

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FILING DATE: 10 February 2004

) Examiner

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FOR: MICRO-NOZZLE, NANO-NOZZLE,

)

MANUFACTURING METHODS

)

THEREFOR, APPLICATIONS

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THEREFOR

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

TRANSMITTAL of NEW PATENT APPLICATION UNDER 37 CFR 1.53

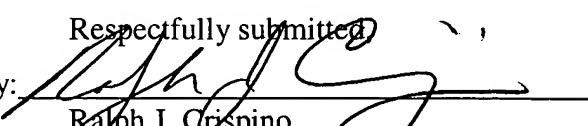
Sir:

Please find enclosed herewith:

- 1) New Patent Application, including:
  - a. Specification ( 25 pages)
  - b. Claims ( 10 pages)
  - c. Abstract ( 1 page)
  - d. Figures ( 28 sheets)
- 2) Return-Postcard

Respectfully submitted

By:

  
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I hereby certify that this correspondence is being deposited with the United States Postal Service "Express Mail Post Office to Addressee" service under 37 CFR 1.10 in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on: February 10, 2004

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